



P/1250-253

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Tatsufumi KUSUDA

Date: September 5, 2003

Serial No.: 10/620,874

Group Art Unit:

Filed: July 16, 2003

Examiner:

For: THERMAL PROCESSING APPARATUS PERFORMING IRRADIATING A
SUBSTRATE WITH LIGHT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art together with a form listing the same
for the convenience of the Examiner.

I hereby certify that this correspondence is being
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2003

Respectfully submitted,

Max Moskowitz
Name of applicant, assignee or
Registered Representative

Signature

September 5, 2003
Date of Signature

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Enclosures

 <p>APPLICANT'S ART CITATION (Use several sheets if necessary)</p>		Application 10/620,874		OFGS File No. P/1250-253		
		Applicant Tatsufumi KUSUDA, et al.				
		Filing Date 7/16/03		Group Art Unit		
U.S. PATENT DOCUMENTS						
▼ Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-4,525,380	06-1985	Arai, et al.			
	US-4,649,261	03-1987	Sheets			
	US-					
	US-					
	US-					
FOREIGN PATENT DOCUMENTS						
	Document Number	Date MM-YYYY	Country	Class	Sub-class	<div style="text-align: center;">Translation</div> <div style="display: flex; justify-content: space-around; font-size: 0.8em;"> Yes No </div>
	11-135449 /	1999	Japan			X
	63-166219 /	1988	Japan			X
	59-169125 /	1984	Japan			X
	60-258928 /	1985	Japan			X
	57-162340 /	1982	Japan			X
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
		English translation of portion of Japanese Patent Application Laid-Open No. 11-135449				
		relevant to the instant application				
		English translation of portion of Japanese Patent Application Laid-Open No. 63-166219				
		relevant to the instant application				
		English translation of portion of Japanese Patent Application Laid-Open No. 57-162340				
		relevant to the instant application				
Examiner		Date Considered				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						